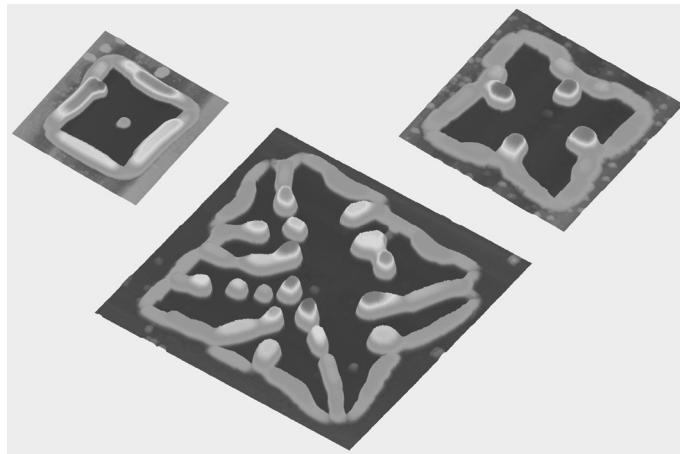


COMPTES RENDUS

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AFM image of the solid-state dewetting of a monocrystalline silicon film on a silica surface (Si/SiO_2).

Image AFM de démouillage en phase solide d'un film monocristallin de silicium sur un substrat de silice (Si/SiO_2).

DOSSIER

Trends and perspectives in solid-state wetting / *Mouillage solide-solide : tendances et perspectives*

Guest editor / Rédacteur en chef invité : Olivier Pierre-Louis

• Trends and perspectives in solid-state wetting Olivier Pierre-Louis	529
• Wetting by solid helium, a model system Sébastien Balibar	531
• One-dimensional Ge nanostructures on $\text{Si}(001)$ and $\text{Si}(1\ 1\ 10)$: Dominant role of surface energy Francesco Montalenti, Daniele Scopece, Leo Miglio	542
• Modeling dewetting of ultra-thin solid films Anna Chame, Olivier Pierre-Louis	553
• A model for solid-state dewetting of a fully-faceted thin film Rachel V. Zucker, Gye Hyun Kim, W. Craig Carter, Carl V. Thompson	564
• Dynamics and instability of solid-state dewetting Fabien Cheynis, Frédéric Leroy, Pierre Müller	578
• Time-dependent analysis of agglomerating Pt thin films on YSZ single crystals Henning Galinski, Thomas Ryll, Lukas Schlagenhauf, Iwan Schenker, Ralph Spolenak, Ludwig J. Gauckler ..	590
• Interfacial reaction during dewetting of ultrathin silicon on insulator Koichi Sudoh, Muneyuki Naito	601

Continued on the next page

Contents (continued)

- Analysis of a combined influence of substrate wetting and surface electromigration on a thin film stability and dynamical morphologies
Mikhail Khenner 607
- Solid-state wetting on nanopatterned substrates
Yukio Saito, Maxime Ignacio, Olivier Pierre-Louis 619
- Droplet spreading: Theory and experiments
Michael J. Davis, Stephen H. Davis 629